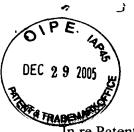




TRANSMITTAL FORM d for all correspondence after initial filing)	Application Number	10/658,472
	Filing Date	September 10, 2003
	First Named Inventor	Hidekazu MIYAIRI et al.
	Group Art Unit	2828

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(to be used for all correspondence after initial filing)		First Named Inventor	Hidekazu MIYAIRI et al.				
		Group Art Unit	2828				
		Examiner Name	Phillip Nguyen				
Total Number of Pages in This S	ubmission	Attorney Docket Number	740756-2650				
ENCLOSURES (check all that apply)							
I hereby certify that this corr	Assi  (for  Draw  Dec  Lice  Petit  App  St Pow Cha  Terr  Req  CD,  S 3  Remarks  SIGNATURE OF AI  Jeffrey L. Costellia  Nixon Peabody LLE  401 9 <sup>th</sup> Street, N.W. Suite 900  Washington, D.C. 2  December 29 2005  TIFICATE OF MAIL  respondence is being: United States Postal velope addressed to:	gnment Papers an Application) ving(s) aration and Power of Attorney asing-related Papers ion ion to Convert to a Provisional ication er of Attorney, Revocation age of Correspondence Address anial Disclaimer aest for Refund Number of CD(s)  The Commissioner is required or credit any over above identified docket nu PLICANT, ATTORNEY, Reg. No. 35,483  ING OR TRANSMISSION Service on the date shown	After Allowance Communication to Group Appeal Communication to Board of Appeals and Interferences Appeal Communication to Group (Appeal Notice, Brief, Reply Brief) Proprietary Information Status Letter Application Data Sheet Request for Corrected Filing Receipt with Enclosures A self-addressed prepaid postcard for acknowledging receipt Other Enclosure(s) (please identify below):  Thereby authorized to charge any additional fees payments to Deposit Account No. 19-2380 for the mber.  OR AGENT				
☐ transmitted by facsimile on the date shown below to the United States Patent and Trademark Office at							
(571) <u>273-8300</u> .							
Date	Date Signature						
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Docket No. 740756-2650



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:	)	
Hidekazu MIYAIRI et al.	)	Group Art Unit: 2828
Serial No. 10/658,472	)	Examiner: Phillip Nguyen
Filed: September 10, 2003	)	Confirmation No. 4070
For: LASER APPARATUS, LASER IRRADIATION METHOD, AND MANUFACTURING METHOD OF SEMICONDUCTOR DEVICE	)	

## RESPONSE TO REQUEST FOR SPECIES ELECTION AND AMENDMENT

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In response to the Request for Restriction Response mailed December 9, 2005, Applicants responds as follows: